



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Kittl et al.	Art Unit:	2829
Serial No.:	10/023,825	Examiner:	Kobert, R.
Filing Date:	12/19/2001	Docket No.:	TI-23892
Customer No.:	23494	Conf. No.:	8239
Title:	METHOD TO IMPROVE SILICIDE FORMATION ON POLYSILICON		

**LETTER OF TRANSMITTAL**

Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(A)  
I hereby certify that the above correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

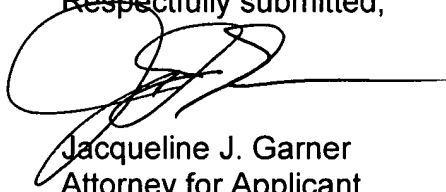
Date

6-24-04  
Marianna Smith  
Marianna Smith

Enclosed please find the signed Supplemental Declaration in the above-identified application.

Please charge any necessary fee to Deposit Account No. 20-0668.

Respectfully submitted,

  
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